

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re patent application of:

Naoki Abe

Confirmation No. 8684

Serial No. 10/749,518

Group Art Unit: 2167

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Examiner: Timblin, Robert M.

For: **RESOURCE-LIGHT METHOD  
FOR OUTLIER DETECTION**

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Commissioner for Patents  
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*entered per  
ROE  
4-12-07*

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Sir:

In response to the Office Action mailed December 12, 2006, please amend the above-identified patent application as follows:

**Listing of the Claims** begins at page 2 of this paper.

**Remarks** begin at page 10 of this paper.